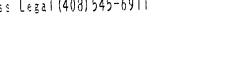
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Case No. 10200/103

DECLARATION FOR PATENT APPLICATION

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name.

I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled In Situ Deposition Of A Nitride Layer And Of An Anti-Reflective Layer, the specification of which:

Situ Deposition	Of A Nitride Layer And Of A	an Anti-Reflective Layer, the specificat	1011 02 1111111111	
\boxtimes	is attached hereto.			
	was filed on as App	ication Serial No		
П		(if applicable).		1 11 - also alaime as
I hereby state	that I have reviewed and und	erstand the contents of the above-iden	tified specification, it	actuding the claims, as
I acknowledge	the duty to disclose informa	tion which is material to the patentable	ility as defined in Th	ication(s) for patent or
inventor's cert	difficate or 9 303(a) of any re	der 35 U.S.C. § 119(a)-(d) or § 365(b) T International application which detentified below, by checking the box, at having a filing date before that of the a	or foreign application	for patent or inventor s
		174 ving 2 vinneg 2 v		Priority Claimed
Prior Foreign	Application(s)			
	er) (Country)	(Day/Month/Year	Filed)	Yes No
(Numb	er) (Country)	· · · ·		below:
	lication Serial No.)	(Filing Date)	 	
I hereby clair application de is not disclos	m the benefit under 35 U.S.C esignating the United States, I ed in the prior United States of	C. § 120 of any United States applications below and, insofar as the subject to PCT International application in the disclose information which is material date of the prior application and the n	manner provided by to patentability as do ational or PCT Intern	the first paragraph of 35 fined in 37 CFR § 1.56 attornal filing date of this
	a tilva	(Filing Date)	(Status-patente	d, pending, abandoned)
I hereby decibelief are be the like so methat such will Inventor's Si	lieved to be true; and turther hade are punishable by fine or liful false statements may jeop	that these statements were made with the imprisonment, or both, under Section ardize the validity of the application or Sharmin Sadoughi	1001 of Title 18 of the any patent issued ther Date:	e United States Code and
Residence		22620 San Juan Rd., Cupertino, CA	1 93014	
Citizenship Post Office	Address	Iran 22620 San Juan Rd., Cupertino, CA	A 95014	

BRINKS HOFER GILSON & LIONE P.O. Box 10395

Chicago, IL 60610

(312) 321-4200

NO. 4865 P. 5

Inventor's Signature	
Full name of second	joint inventor, if any
Residence	
Citizenship	
Post Office Address	

Kraucell	Date:	11/5/01
Krishnaswamy Ramkumar		
1193 Lynbrook Wy., San Jose, CA 95129		
India		

Cypress Legal (408) 545-6911

NO. 4872 P. 2

Case No. 10200/103

Inventor(s):

Sharmin Sas shi and Krishnaswamy Ramkumar

Title:

IN SITU DEPOSITION OF A NITRIDE LAYER AND OF AN ANTI-REFLECTIVE LAYER

•	YOWER OF ATTORNEY				
	The specification of the above-identified patent application:				
\boxtimes	attached hereto as filed on as application Serial No.				
attorncy	I hereby revoke all previously granted powers of attorney in the above-identified patent application and appoint the following ys to prosecute said patent application and to transact all business in the Patent and Trademark Office connected therewith:				
	Paul E. Rauch, Ph.D Reg. No. 38,591				
	David Rozenblat - Reg. No. 47,044				
	Andrew D. Fortney, Ph.D Reg. No. 34,600				
	Please address all correspondence and telephone calls to David Rozenblat in care of:				
	Brinks Hofer Gilson & Lione P.O. Box 10395 Chicago, IL 60610 (312)321-4200				
ihe pate	Cypress Semiconductor Corp., a Delaware corporation, certifies that it is the assignce of the entire right, title and interest in application identified above by virtue of either:				
	An assignment from the inventor(s) of the patent application identified above, a copy of which is attached hereto. OR				
	An assignment from the inventor(s) of the patent application identified above. The assignment was recorded in the Patent and Trademark Office at Reel, frame OR				
	A chain of title from the inventor(s), of the patent application identified above, to the current assignee as shown below:				
÷	 From To: The document was recorded in the Patent and Trademark Office at Reel, frame, or a copy thereof is attached. 				
	2. From To: The document was recorded in the Patent and Trademark Office at Reel, frame, or a copy thereof is attached.				
· -	Additional documents in the chain of title are listed on a supplemental sheet.				
above a	The undersigned has reviewed the assignment or all the documents in the chain of title of the patent application identified nd, to the best of undersigned's knowledge and belief, title is in the assignee identified above.				
	The undersigned (whose title is supplied below) is empowered to act on behalf of the assignee.				
ike so r	I hereby declare that all statements made herein of my own knowledge are true, and that all statements made on information ief are believed to be true; and further, that these statements are made with the knowledge that willful false statements, and the made, are punishable by fine or imprisonment, or both, under Section 1001. Title 18 of the United States Code, and that such false statements may jeopardize the validity of the application or any patent issuing thereon.				
Signatui Name:	re Andrew D. Fortney, Ph.D., Esq.				
Title:	Senior Corporate Counsel/Director of Intellectual Property				
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